

INFO	ORMATION	N DISCLO	ATTY. DOCKET NO. 1268-093A		SERIAL NO. Not Yet Assigned			
	CITATIO APPLIC		OIPE	APPLICANT Moshe FINAROV				
(PTO-1449) FEB 2 6 2001				FILING DATE July 26, 2000		GROUP		
		1	PATEMEDO	CUMENTS		===x>		
EXAMINER'S INITIALS	PATENT NO.	DATE	NAME		CLASS	SUBCLASS	FILING DATE	
FSE.	5,604,344	2/1997	Finarov					
DBE_	5,682,242	10/1997	Eylon			000		- <del>-</del>
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		FOI	REIGN PATENT	DOCUMENTS				
EXAMINER'S INITIALS	PATENT NO.	DATE	COUNTRY		CLASS	SUBCLASS	Translation Yes No	
185	95/11446	04/27/95	W.I.P.O.					
DBE	9-50959	02/18/97	JAPAN					
THE	0 412 728	02/13/91	E.P.O.					
	OTHI	CR ART (Incl	uding Author, Ti	tle, Date, Pertinen	t Pages, Etc	e.) 		
DEE	Dishon et al., "Monitoring Choices of CMP Planarization Processes", pp. 1-10, Feb. 1997.							
DEE	English Language Abstract of JP 9-50959.							
EXAMINER DE			D	ATE CONSIDERE 3/5/63	D			

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.